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Attorney's Docket No.: 42390P10305

PATENT**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of )

Murali, Venkatesan )

Examiner: Chen, Kin Chan )

Application No.: 09/741,532 )

Art Unit: 1765 )

Filing Date: December 19, 2000 )

For: METHOD OF CREATING A  
PHOTONIC VIA USING  
DEPOSITION )Assistant Commissioner for Patents  
Washington, D.C. 20231  
ATTN: BOX AFFAX RECEIVED  
JAN 07 2003  
GROUP 1700RESPONSE AND AMENDMENT AFTER FINAL

Sir:

In response to the Office Action mailed October 7, 2002, Applicant respectfully requests the Examiner to enter the following amendments and consider the following remarks:

IN THE CLAIMS:

Please amend the claims as follows:

- C1
- 1 1. (Twice Amended) A method of making a photonic via comprising:
  - 2 making a hole in a substrate, wherein the hole extends from one side of
  - 3 the substrate through the substrate to an opposite side of the substrate;